

Jonathan Pelz

List of Publications by Year in descending order

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19
papers

362
citations

1040056

9
h-index

1058476

14
g-index

19
all docs

19
docs citations

19
times ranked

375
citing authors

#	ARTICLE	IF	CITATIONS
1	Local trap spectroscopy on cross-sectioned AlGaIn/GaN devices with <i>in situ</i> biasing. Applied Physics Letters, 2019, 114, .	3.3	2
2	Correlative Defect Characterization in Semiconductors via Electron Channeling Contrast Imaging and Scanning Deep Level Transient Spectroscopy. Microscopy and Microanalysis, 2018, 24, 1056-1057.	0.4	0
3	Spatial correlation of the EC-0.57 eV trap state with edge dislocations in epitaxial n-type gallium nitride. Journal of Applied Physics, 2018, 123, .	2.5	11
4	Direct nm-scale spatial mapping of traps in CIGS. , 2015, , .		0
5	Direct nm-Scale Spatial Mapping of Traps in CIGS. IEEE Journal of Photovoltaics, 2015, 5, 1482-1486.	2.5	32
6	Correlation of electrical spin injection and non-linear charge-transport in Fe/MgO/Si. Applied Physics Letters, 2013, 103, .	3.3	17
7	Spatially-resolved spectroscopic measurements of <i>Ec</i> \sim 0.57 eV traps in AlGaIn/GaN high electron mobility transistors. Applied Physics Letters, 2013, 102, .	3.3	91
8	Nm-scale measurements of fast surface potential transients in an AlGaIn/GaN high electron mobility transistor. Applied Physics Letters, 2012, 100, .	3.3	31
9	Nanoscale Characterization of Metal/Semiconductor Nanocontacts. AIP Conference Proceedings, 2005, , .	0.4	0
10	Calculated potential profile near charged threading dislocations at metal/semiconductor interfaces. Journal of Applied Physics, 2002, 92, 6010-6013.	2.5	6
11	Relaxed InAsP layers grown on step graded InAsP buffers by solid source MBE. Materials Research Society Symposia Proceedings, 2002, 722, 1021.	0.1	4
12	OBSERVATION OF DIRECT-CURRENT-INDUCED STEP BENDING PATTERNS ON Si(001). Surface Review and Letters, 2000, 07, 577-582.	1.1	3
13	Ultrahigh vacuum dual fluid line rotatable connector. Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films, 1999, 17, 674-675.	2.1	0
14	Nanometer-scale investigation of metal-SiC interfaces using ballistic electron emission microscopy. Journal of Electronic Materials, 1998, 27, 345-352.	2.2	19
15	Investigation of ultrathin SiO ₂ film thickness variations by ballistic electron emission microscopy. Journal of Vacuum Science & Technology an Official Journal of the American Vacuum Society B, Microelectronics Processing and Phenomena, 1998, 16, 2302.	1.6	9
16	Ballistic-electron emission microscopy studies of charge trapping in SiO ₂ . Journal of Vacuum Science & Technology an Official Journal of the American Vacuum Society B, Microelectronics Processing and Phenomena, 1996, 14, 2864.	1.6	42
17	Evolution of atomic-scale roughening on Si(001) $\sqrt{2}\times\sqrt{2}$ surfaces resulting from high temperature oxidation. Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films, 1995, 13, 772-776.	2.1	54
18	Elevated temperature oxidation and etching of the Si(111) $\sqrt{7}\times\sqrt{7}$ surface observed with scanning tunneling microscopy. Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films, 1993, 11, 1649-1653.	2.1	41

#	ARTICLE	IF	CITATIONS
19	Alignment of Adsorbate-Induced Defects on Silicon(001) 2\AA -1 Observed with STM. Materials Research Society Symposia Proceedings, 1993, 318, 25.	0.1	0